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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Ramachandran, et al.	Docket No.:	INTECH 3.0-081 (2002 P 15180 US)
Serial No.:	10/685,684	Art Unit:	1746
Filed:	October 15, 2003	Examiner:	El Arini, Zeinab

For: Semiconductor Device Cleaning Employing Heterogeneous Nucleation for Controlled Cavitation

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Commissioner for Patents
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Amendment Filed under 37 C.F.R. § 1.116

Dear Sir:

The following amendments and remarks are offered in response to Examiner's Office Action dated February 22, 2007, a final rejection. Applicants respectfully request that this amendment be entered pursuant to the provisions of 37 C.F.R. § 1.116, and respectfully request reconsideration of claims 1-24.

PAGE 2/9 * RCVD AT 4/20/2007 4:05:20 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-6/42 * DNIS:2738300 * CSID:9727329218 * DURATION (mm-ss):01-56